



Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 12816-027001	Application No. 09/914,749
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Wilhelm Kegel et al	
		Filing Date September 4, 2001	Group Art Unit 2812

U.S. Patent Documents

Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
<i>De</i>	AA	5,637,528	06/10/1997	Higashitani et al.	438	452	
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
<i>De</i>	AL	99 03141	01/21/1999	WO	H01L	21/316		
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
<i>De</i>	AQ	Moslehi, M.M., "Single-wafer optical processing of semiconductors: Thin insulator growth for integrated electronic device applications", Applied Physics A (Solids and Surfaces), Aug. 1988, vol. A46, no. 4, pages 255-273.
	AR	International Search Report

Examiner Signature <i>Dring Aug 6</i>	Date Considered <i>4/03</i>
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

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